

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor Dinesh Chopra
Assignee Micron Technology, Inc.
Priority Group Art Unit 2825
Priority Examiner L. Malsawma
Attorney's Docket No. MI22-2345
Title: Conductive Connection Forming Methods, Oxidation Reducing Methods, and
Integrated Circuits Formed Thereby

PRELIMINARY AMENDMENT

To: MS Patent Application
Commissioner for Patents
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Introductory Comments

The present Response is submitted in the Revised Amendment Format and
therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

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